



1724

In re the Application of:

Dae-Won KIM, et al.

Art Unit: 1724

Serial No. 10/684,409

Examiner: Minh Chau Thi Pham

Filed: October 15, 2003

Confirmation No. 4381

For: MULTI-LAYER FILM FOR THIN FILM
STRUCTURE, CAPACITOR USING THE SAME
AND FABRICATION METHOD THEREOF

Attorney Docket No. 253/039

REPLY UNDER 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Va. 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office action dated January 19, 2006, the following remarks are respectfully submitted in connection with the above-identified application:

A Listing of the Claims begins on page 2 of this paper.

Remarks begin on page 9 of this paper.